

L Number	Hits	Search Text	DB	Time stamp
-	28	"4866108"	USPAT; EPO; JPO; DERWENT	2001/06/27 14:12
-	307516	epoxy	USPAT; EPO; JPO; DERWENT	2001/06/27 14:13
-	5319	outgassing	USPAT; EPO; JPO; DERWENT	2001/06/27 14:13
-	3	"4866108" and epoxy and outgassing	USPAT; EPO; JPO; DERWENT	2001/06/27 14:16
-	3	("4866108" and epoxy and outgassing) and stoichiometric	USPAT; EPO; JPO; DERWENT	2001/06/27 14:36
-	51850	epoxy same adhesive	USPAT; EPO; JPO; DERWENT	2001/06/27 14:36
-	150975	optics	USPAT; EPO; JPO; DERWENT	2001/06/27 14:37
-	16	outgassing and (epoxy same adhesive) and optics	USPAT; EPO; JPO; DERWENT	2001/06/27 14:48
-	789571	vacuum or reduced adj pressure	USPAT; EPO; JPO; DERWENT	2001/06/27 14:49
-	1682	outgassing same (vacuum or reduced adj pressure)	USPAT; EPO; JPO; DERWENT	2001/06/27 14:50
-	248	epoxy and (outgassing same (vacuum or reduced adj pressure))	USPAT; EPO; JPO; DERWENT	2001/06/27 14:50
-	72	(epoxy and (outgassing same (vacuum or reduced adj pressure))) and mounting	USPAT; EPO; JPO; DERWENT	2001/06/27 17:15
-	1548	epoxy same optics	USPAT; EPO; JPO; DERWENT	2001/06/27 14:55
-	351	(epoxy same adhesive) same optics	USPAT; EPO; JPO; DERWENT	2001/06/27 14:55
-	0	((epoxy same adhesive) same optics) and outgassing	USPAT; EPO; JPO; DERWENT	2001/06/27 14:58
-	23	(epoxy and (outgassing same (vacuum or reduced adj pressure))) and optics	USPAT; EPO; JPO; DERWENT	2001/06/27 15:05
-	25	TML and (CVCM or CVM)	USPAT; EPO; JPO; DERWENT	2001/06/27 15:20
-	0	epoxy and optics and (TML and (CVCM or CVM))	USPAT; EPO; JPO; DERWENT	2001/06/27 15:21
-	20	epoxy and (TML and (CVCM or CVM))	USPAT; EPO; JPO; DERWENT	2001/06/27 15:43
-	5	(TML and (CVCM or CVM)) not (epoxy and (TML and (CVCM or CVM)))	USPAT; EPO; JPO; DERWENT	2001/06/27 15:47
-	2	(optics same outgas\$4) same contaminat\$2	USPAT; EPO; JPO; DERWENT	2001/06/27 15:48

-	50	optics same outgas\$4	USPAT; EPO; JPO; DERWENT	2001/06/27 15:58
-	219	(mounting with optics).ti.	USPAT; EPO; JPO; DERWENT	2001/06/27 15:50
-	0	(optics same outgas\$4) and ((mounting with optics).ti.)	USPAT; EPO; JPO; DERWENT	2001/06/27 15:51
-	0	((mounting with optics).ti.) and outgas\$4	USPAT; EPO; JPO; DERWENT	2001/06/27 15:51
-	1	((mounting with optics).ti.) and contaminat\$2	USPAT; EPO; JPO; DERWENT	2001/06/27 15:51
-	7	(optics same outgas\$4) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/27 17:18
-	1073	epoxy same (thermal adj expansion adj coefficient)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:32
-	0	(epoxy same (thermal adj expansion adj coefficient)) and ((mounting with optics).ti.)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:18
-	16	epoxy and ((mounting with optics).ti.)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:20
-	2	(epoxy same adhesive) and ((mounting with optics).ti.)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:21
-	168	(epoxy same (thermal adj expansion adj coefficient)) and optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/27 16:32
-	515	epoxy with (thermal adj expansion adj coefficient)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:32
-	72	(epoxy with (thermal adj expansion adj coefficient)) and optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/27 16:36
-	6114	interferometer.ti.	USPAT; EPO; JPO; DERWENT	2001/06/27 16:38
-	2	(epoxy same adhesive) and interferometer.ti.	USPAT; EPO; JPO; DERWENT	2001/06/27 16:37
-	92	interferometer and (epoxy same optics)	USPAT; EPO; JPO; DERWENT	2001/06/27 16:38
-	6	"5367006"	USPAT; EPO; JPO; DERWENT	2001/06/27 17:32
-	37661	optical adj device	USPAT; EPO; JPO; DERWENT	2001/06/27 17:34
-	660	(epoxy same adhesive) and (optical adj device)	USPAT; EPO; JPO; DERWENT	2001/06/28 09:15
-	8	((epoxy same adhesive) and (optical adj device)) and outgassing	USPAT; EPO; JPO; DERWENT	2001/06/27 17:35
-	38	(epoxy same adhesive) and (mounting with optical adj device)	USPAT; EPO; JPO; DERWENT	2001/06/28 11:11

-	3	4863090.pn.	USPAT; EPO; JPO; DERWENT	2001/06/28 09:31
-	329	epoxy and outgas\$4 and optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/28 10:33
-	2673	(adhesi\$2 with optic\$2).ti.	USPAT; EPO; JPO; DERWENT	2001/06/28 10:24
-	243	((adhesi\$2 with optic\$2).ti.) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 10:24
-	90	(epoxy with adhesi\$2 with optic\$2).ti.	USPAT; EPO; JPO; DERWENT	2001/06/28 10:30
-	0	((epoxy with adhesi\$2 with optic\$2).ti.) and outgas\$4	USPAT; EPO; JPO; DERWENT	2001/06/28 10:32
-	0	(((adhesi\$2 with optic\$2).ti.) and epoxy) and outgas\$4	USPAT; EPO; JPO; DERWENT	2001/06/28 10:32
-	304	outgas\$4 same optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/28 10:33
-	56	(outgas\$4 same optic\$2) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 11:12
-	2884	(mounting or assembling) with optics	USPAT; EPO; JPO; DERWENT	2001/06/28 13:40
-	258	((mounting or assembling) with optics).ti.	USPAT; EPO; JPO; DERWENT	2001/06/28 11:12
-	20	((mounting or assembling) with optics).ti.) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 11:15
-	5	"5311610"	USPAT; EPO; JPO; DERWENT	2001/06/28 11:18
-	1	"5311610" and outgassing	USPAT; EPO; JPO; DERWENT	2001/06/28 11:19
-	25	interferometer and outgassing	USPAT; EPO; JPO; DERWENT	2001/06/28 11:23
-	2	interferometer.ti. and epoxy with adhesive	USPAT; EPO; JPO; DERWENT	2001/06/28 11:26
-	420	mounting same optic\$2 same epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 12:32
-	17	(mounting same optic\$2 same epoxy) and interferometer	USPAT; EPO; JPO; DERWENT	2001/06/28 11:36
-	28	outgassing and mirror same contaminat\$3	USPAT; EPO; JPO; DERWENT	2001/06/28 11:37
-	6	(outgassing and mirror same contaminat\$3) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 11:40
-	3724	epoxy with storage	USPAT; EPO; JPO; DERWENT	2001/06/28 11:41

-	1	((mounting or assembling) with optics) and (epoxy with storage)	USPAT; EPO; JPO; DERWENT	2001/06/28 11:44
-	625	outgas\$4 with problem	USPAT; EPO; JPO; DERWENT	2001/06/28 11:44
-	1	((mounting or assembling) with optics) and (outgas\$4 with problem)	USPAT; EPO; JPO; DERWENT	2001/06/28 11:45
-	41	(outgas\$4 with problem) same epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 11:46
-	14	((outgas\$4 with problem) same epoxy) and optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/28 11:50
-	678	epoxy with bond\$3 with optic\$2	USPAT; EPO; JPO; DERWENT	2001/06/28 11:58
-	39	(epoxy with bond\$3 with optic\$2).ti.	USPAT; EPO; JPO; DERWENT	2001/06/28 11:59
-	62	(mounting same optic\$2 same epoxy) same method	USPAT; EPO; JPO; DERWENT	2001/06/28 12:33
-	34	(method with (mounting or assembling) with optics).ti.	USPAT; EPO; JPO; DERWENT	2001/06/28 13:41
-	7	((method with (mounting or assembling) with optics).ti.) and epoxy	USPAT; EPO; JPO; DERWENT	2001/06/28 13:41
-	9	(epoxy with bond\$3 with optic\$2) same ((mounting same optic\$2 same epoxy) same method)	USPAT; EPO; JPO; DERWENT	2001/06/28 14:03